



## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
 United States Patent and Trademark Office  
 Address: COMMISSIONER FOR PATENTS  
 P.O. Box 1450  
 Alexandria, Virginia 22313-1450  
 www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 5527

SERIAL NUMBER 10/665,473	FILING DATE 09/22/2003 RULE	CLASS 428	GROUP ART UNIT 1775	ATTORNEY DOCKET NO. 242859US0DIV
-----------------------------	-----------------------------------	--------------	------------------------	--

## APPLICANTS

Hitoshi Sakamoto, Kanagawa, JAPAN;

Toshihiko Nishimori, Hyogo, JAPAN;

Hiroshi Sonobe, Nagasaki, JAPAN; Yoshimichi Yonekura, Kanagawa, JAPAN;  
Nobuki Yamashita, Kanagawa, JAPAN;\*\* CONTINUING DATA *YOS*

This application is a DIV of 09/880,932 06/15/2001 ABN

\*\* FOREIGN APPLICATIONS *et. al. Parent*

JAPAN 2000-193734 06/28/2000

JAPAN 2001-067042 03/09/2001

JAPAN 2001-120272 04/18/2001

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 12/12/2003

Foreign Priority claimed	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY	SHEETS DRAWING	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	JAPAN	9	15	9
Verified and Acknowledged	Examiner's Signature <i>AP</i> Initials <i>AP</i>				

## ADDRESS

22850  
 OBLON, SPIVAK, MCCLELLAND, MAIER & NEUSTADT, P.C.  
 1940 DUKE STREET  
 ALEXANDRIA, VA  
 22314

## TITLE

Hexagonal boron nitride film with low dielectric constant, layer dielectric film and method of production thereof, and plasma CVD apparatus

All Fees